IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicants: Ralf LERNER Group Art Unit: Not yet assigned

Appin. No. : 10/552,984 Examiner: Not yet assigned

I.A. Filed April 19, 2004

TEST STRUCTURE FOR LECTRICALLY VERIFYING THE DEPTHS OF FOF

TRENCH-ETCHING IN AN SOI WAFER, AND ASSOCIATED WORKING

METHODS

POWER OF ATTORNEY

Commissioner for Patents U.S. Patent and Trademark Office Customer Window, Mail Stop Randolph Building 401 Dulany Street Alexandria, VA 22314

The undersigned assignee of the entire right, title and interest in the above-identified case, as evidenced by the attached copy of the executed Assignment, hereby appoints the attorneys and agents associated with

Customer Number 07055

to prosecute said application and to transact all business in the Patent and Trademark Office connected therewith.

The appointed attorneys and agents include:

Neil F. Greenblum Arnold Turk James L. Rowland Stephen M. Roylance Robert W. Mueller	Reg. No. 28,394 Reg. No. 33,094 Reg. No. 32,674 Reg. No. 31,296 Reg. No. 35,043	Bruce H. Bernstein Reg. No. 29,027 William E. Lyddane Reg. No. 41,568 William Pieprz Reg. No. 33,630 Leslie J. Paperner Reg. No. 33,329
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at:

GREENBLUM & BERNSTEIN, P.L.C. 1950 Roland Clarke Place Reston, Virginia 20191

The undersigned representative is empowered to act on behalf of the assignee, and it is certified that to the best of the undersigned's knowledge and belief, title is in the assignee.

10. August 2006

Date

Respectfully submitted,

X-FAB SEMICONDUCTOR FOUNDARIES

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* - NAME - TITLE

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